Attorney Docket: D900D/1368D

#### CERTIFICATE OF MAIL

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner for Patents and Trademarks, Washington, D.C. 20231, on April 19, 2002.

Grace Alicea

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Date: April 19, 2002

Marina V. PLAT and Angela T. HUI

Serial No.: 10/079,775

Group Art Unit: 2823

Filed: February 19, 2002

Examiner: To Be Assigned

METHOD AND SYSTEM FOR REDUCING ARC LAYER REMOVAL For:

**DURING REMOVAL OF PHOTORESIST** 

Office of Initial Patent Examination Customer Service Center Assistant Commissioner of Patents Washington, D.C. 20231

## TRANSMITTAL LETTER

Sir:

Please find enclosed the following:

- 1) Transmittal Letter (original and one copy)
- 2) Request for Corrected Filing Receipt
- 3) Copy of Marked-Up Filing Receipt
- 4) Postcard

The Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account 02-2120 (Sawyer Law Group LLP). If any unresolved issues remain, please contact Applicant's attorney at the telephone number below.

Respectfully submitted,

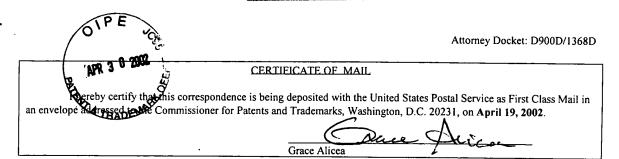
April 19, 2002

Date

Reg. No. 30,801

Sawyer Law Group LLP Attorney for Applicant

(650) 493-4540



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### REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.

In the Priority Date section, please remove "09/433,541 11/03/99" and replace with --09/433,591 11/02/99--.

The Commissioner is hereby authorized to charge any fees or credit any overpayment associated with this communication to Deposit Account 02-2120 (Sawyer Law Group LLP).

Respectfully submitted,

April 19, 2002

Attorney for Applicant

Reg. No. 30,801 (650) 493-4540



Page 1 of 2

TENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS UNITED STATES PATENT AND TRADEMARK OFFICE WASHINGTON D.C. 20231

www.uspto.gov APPLICATION NUMBER FILING DATE **GRP ART UNIT** FIL FEE REC'D ATTY.DOCKET.NO DRAWINGS TOT CLAIMS IND CLAIMS 10/079,775 02/19/2002 2823 740 D900D/1368D

**CONFIRMATION NO. 9123** 

SAWYER LAW GROUP LLP P.O. Box 51418 Palo Alto, CA 94303

**FILING RECEIPT** \*OC000000007633385\*

Date Mailed: 03/14/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE. NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Marina V. Plat, San Jose, CA; Angela T. Hui, Fremont, CA;

Domestic Priority data as claimed by applicant

09/433,591

THIS APPLICATION IS A DIV OF 09/433.544

(\*) Data inconsistent with PTO records.

Foreign Applications

If Required, Foreign Filing License Granted 03/13/2002

Projected Publication Date: 06/20/2002

Non-Publication Request: No

Early Publication Request: No

Title

Method and system for reducing ARC layer removal during removal of photoresist

**Preliminary Class** 

438